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BIBDATASHEET

Bib Data Sheet

CONFIRMATION NO. 5687

	SERIAL NUMB 10/716,556	RULE		CLASS 438		GROUP ART UNIT 2813		ATTORNEY DOCKET NO. 245469US2DIV		
	APPLICANTS Tadashi Iguchi, Yokkaichi-Shi, JAPAN; Yoshiaki Himeno, Yokkaichi-Shi, JAPAN; Hiroaki Tsunoda, Yokkaichi-Shi, JAPAN; *** CONTINUING DATA ******************************* This application is a DIV of 09/732,723 12/11/2000 PAT 6,720,610 *** FOREIGN APPLICATIONS ************************************									
	Foreign Priority claimed				STATE OR COUNTRY JAPAN			TOTAL CLAIMS 9		INDEPENDENT CLAIMS 3
	22850									
μI .	TITLE Method of manufacturing a nonvolatile semiconductor memory device having a stacked gate structure									
	FILING FEE FEES: Authority has been given in Paper RECEIVED No to charge/credit DEPOSIT ACCOUNT 770 No for following:					All Fees 1.16 Fees (Filing) 1.17 Fees (Processing Ext. of time) 1.18 Fees (Issue) Other Credit				